



Juliette van der Meer joined Bruker since 2008 as an Application Scientist for semiconductor X-ray applications. Currently she is a member of the X-ray business unit of the Nano Surfaces and Metrology Division and is the Product Marketing Manager for the automated XRD solutions for the semiconductor industry. In addition, she manages the collaborations between Bruker and EU partners in advanced technology projects. Juliette has a background in material science, with focus on thermodynamics. She obtained her Ph.D. at Utrecht University in the Netherlands. After that she did a postdoc in surface chemistry at the CNRS Marcoule, in France. It was during this project where she gained vast experience in X-ray techniques such as GIXRD and SAXS on mesoporous material. She is based in Karlsruhe, Germany.